THE POSSIBILITIES ARE INFINITE FUITSU

The Fujitsu Analog and RF CMOS Technology



Description

Building on Fujitsu's expertise in leading-edge CMOS processes and analog design capabilities, the company's RF CMOS technologies are optimized for wireless networks, cellular communication, WiMAX, digital multi-media broadcast, and navigational applications.

The foundation of Fujitsu's RF CMOS technologies is its low-leakage processes with transistors capable of switching frequencies well in excess of 100GHz. The processes also feature triple-well for better noise isolation. High-quality passive devices such as a high-value resistor, Metal-Insulator-Metal (MIM) capacitor and thick copper inductor complete the requirements for high-performance RF systems.

Features

Process Technology

- 90nm and 65nm low leakage processes
- Triple-well isolation
- MOS varactor
- High-value poly resistor
- Metal-Insulator-Metal (MIM) and MOS capacitors
- Thick metal inductor
- Full low-K and ultra-low-K inter-metal dielectric

Highly accurate, surface-potential-based PSP and traditional BSIM transistor models are provided in the design kit. PSP provides excellent modeling of gate and channel noise and better high-order analysis of signal distortion. An inductor toolbox provides scalable and precise models and parameterized layout cells. The sophisticated statistical simulation environment allows engineers to evaluate process sensitivity and explore design options.

Fujitsu's RF CMOS technology reduces the complexity of high-frequency RF design. The technology is the ideal platform for complete RF SoC designs for the most advanced wireless applications.

Design Kit

- PSP-and BSIM-based transistor models
- Speciality MOSVAR varactor models
- Inductor synthesis toolbox
- Flexible corner X-SIGMA design system
- PCM-based model validation tool
- Advanced statistical analysis and simulation environment
- Comprehensive IP portfolio and standard EDA tool flow

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Applications

- Wireless networking (IEEE 802.11x, WiMAX)
- Cellular telephone (3G, 4G LTE)
- Bluetooth
- Digital multimedia broadcast
- Wireless audio/video
- Navigational systems

Specifications

• Wireless sensor network

• Wireless USB

- RFID
- High speed wireline network
- Precision analog

	90nm	65nm
Transistors	Core voltage: 1.0V-1.2V	• Core voltage: 1.0V-1.2V
	Core transistors: Hvt, Svt, Lvt	Core transistors: Hvt*, Svt, Lvt
	• I/O transistors: 1.8V / 2.5V / 3.3V	 I/O transistors: 1.8V / 3.3V
	 Double- and triple-well (DNW) 	 Double- and triple-well (DNW)
	Vertical PNP	Vertical PNP
Capacitors	• MIM: 1.0 / 1.5 fF/µm ²	• MIM density 1.0 / 1.5 fF/ μ m ²
	• MOS: 4.4 fF/µm ² (3.3V)	• MOS: 4.5 fF/µm ² (3.3V)
Varactor	• MOS (1.2V / 2.5V / 3.3V)	• MOS (1.2V / 1.8V / 3.3V)
Resistors	Silicided poly: 11 ohm/sq	• Silicided poly: 20 ohm/sq
	 Unsilicided poly: 450 ohm/sq 	 Unsilicided poly: 480 ohm/sq
Inductors	Single-ended/differential	• Single-ended/differential
	 Single layer and stacked copper 	 Single layer and stacked copper
	 Integrated ground shield technology 	 Integrated ground shield technology
	• Thick copper: 3.3µm	• Thick copper: 3.3µm
Metal	• Up to 10 metal layers	Up to 12 metal layers
	Full low-K inter-metal dielectric	Ultra low-K inter-metal dielectric
	• Flip chip redistribution layer: 1.17µm Al	• Flip chip redistribution layer: 1.17µm Al

*Hvt: Long-channel Svt.

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